



Attorney Docket No. 108298714US
Disclosure No. 03-0116.00/US

PTO/SB/08a/b (08-03)
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U.S. Patent and Trademark Office; U.S. DEPARTMENT OF COMMERCE

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Substitute for form 1449A/B/PTO				Complete If Known	
				Application Number	10/767,298-Conf.# 5002
				Filing Date	January 28, 2004
				First Named Inventor	Lingyi A. Zheng
				Art Unit	2824- 2891
				Examiner Name	Michael K. Luhrs-
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U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (if known)			
C.C.		US-11/027,825	Filed 12-29-2004	Derderian et al.	
		US-10/933,604	Filed 09-02-2004	Carpenter et al.	
		US-10/687,458	Filed 10-15-2003	Kublsta et al.	
		US-10/683,424	Filed 10-10-2003	Mardian	
		US-10/839,316	Filed 05-05-2004	Saragiannis et al.	
		US-10/814,573	Filed 03-31-2004	Gealy et al.	
		US-11/043,629	Filed 01-25-2005	Rueger et al.	
		US-11/018,142	Filed 12-20-2004	Rueger et al.	
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		US-10/859,883	Filed 06-02-2004	Miller et al.	
		US-10/683,606	Filed 10-09-2003	Derderian	
		US-10/733,523	Filed 10-10-2003	Beaman et al.	
		US-11/027,809	Filed 12-29-2004	Carpenter et al.	
		US-579,269	03-23-1897	Hent	
		US-3,618,919	11-09-1971	Beck	
		US-3,620,934	11-16-1971	Endle	
		US-3,630,881	12-28-1971	Lester et al.	
V		US-3,630,769	12-28-1971	Hart et al.	
C.C.		US-3,634,212	01-11-1972	Valayil et al.	

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				Examiner Name	Michael K. Lehrs
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C C	US-4,018,949	04-19-1977	Donokowski et al.	
↑	US-4,242,182	12-30-1980	Popescu	
↑	US-4,269,625	05-26-1981	Molenaar	
↑	US-4,289,061	09-15-1981	Emmett	
↑	US-4,397,753	08-09-1983	Czaja	
↑	US-4,438,724	03-27-1984	Doehler et al.	
↑	US-4,469,801	09-04-1984	Hirai et al.	
↑	US-4,545,136	10-08-1985	Izu et al.	
↑	US-4,590,042	05-20-1986	Drage	
↑	US-4,681,777	07-21-1987	Engelken et al.	
↑	US-4,826,579	05-02-1989	Westfall	
↑	US-4,948,979	08-14-1990	Munakata et al.	
↑	US-4,949,669	08-21-1990	Ishii et al.	
↑	US-4,966,646	10-30-1990	Zdeblick	
↑	US-4,977,106	12-11-1990	Smith	
↑	US-5,076,205	12-31-1991	Vowles et al.	
↑	US-5,091,207	02-25-1992	Tanaka	
↑	US-5,131,752	07-21-1992	Yu et al.	
↑	US-5,136,975	08-11-1992	Bartholomew et al.	
↑	US-5,172,849	12-22-1992	Barten et al.	
↑	US-5,200,023	04-06-1993	Gifford et al.	
↑	US-5,223,113	06-29-1993	Kaneko et al.	
↑	US-5,232,749	08-03-1993	Gilton	
↑	US-5,248,527	09-28-1993	Uchida et al.	
↑	US-5,364,219	11-15-1994	Takahashi et al.	
↑	US-5,377,429	01-03-1995	Sandhu et al.	
↑	US-5,380,396	01-10-1995	Shikida et al.	
↑	US-5,409,129	04-25-1995	Tsukada et al.	
↑	US-5,418,180	05-23-1995	Brown	
↑	US-5,427,666	06-27-1995	Mueller et al.	
↓	US-5,433,835	07-18-1995	Demaray et al.	
C C	US-5,445,491	08-29-1995	Nakagawa et al.	

Examiner Signature	C. Chaudhari	Date Considered	10-05
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet	3	of	13
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C C	US-5,480,818	01-02-1996	Matsumoto et al.
A	US-5,498,292	03-12-1996	Ozaki
	US-5,500,256	03-19-1996	Watabe
	US-5,522,934	06-04-1996	Suzuki et al.
	US-5,536,317	07-16-1996	Crain et al.
	US-5,562,800	10-08-1996	Kawamura
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	US-5,643,394	07-01-1997	Maydan et al.
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	US-5,788,778	08-04-1998	Shang et al.
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	US-5,833,888	11-10-1998	Arya et al.
	US-5,846,330	12-08-1998	Quirk et al.
	US-5,846,275	12-08-1998	Lane et al.
	US-5,851,849	12-22-1998	Comizzoli et al.
	US-5,865,417	02-02-1999	Harris et al.
V	US-5,879,459	03-09-1999	Gadgil et al.
C C	US-5,895,530	04-20-1999	Shrotriya et al.

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				Examiner Name	Michael K. Luhrs
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C C	US-5,908,947	06-01-1999	Vaartstra	
↑	US-5,932,286	08-03-1999	Beinglass et al.	
	US-5,953,634	09-14-1999	Kajita et al.	
	US-5,956,613	09-21-1999	Zhao et al.	
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	US-5,997,588	12-07-1999	Goodwin et al.	
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	US-6,042,652	03-28-2000	Hyun et al.	
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	US-6,059,885	05-09-2000	Ohashi et al.	
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	US-6,070,551	06-06-2000	Li et al.	
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	US-6,144,060	11-07-2000	Park et al.	
	US-6,149,123	11-21-2000	Harris et al.	
	US-6,160,243	12-12-2000	Cozad	
↓	US-6,161,500	12-19-2000	Kopacz et al.	
C C	US-6,174,366	01-18-2001	Ihantola	

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				Art Unit	2824- 2891
				Examiner Name	Michael K. Lehr
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<u>C C</u>	US-6,174,377	01-16-2001	Doering et al.	
<u>A</u>	US-6,174,809	01-16-2001	Kang et al.	
	US-6,173,673	01-16-2001	Golovato et al.	
	US-6,178,660	01-30-2001	Emmi et al.	
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	US-6,197,119	03-06-2001	Dozoretz et al.	
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	US-6,203,613	03-20-2001	Gates et al.	
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	US-6,270,572	08-07-2001	Kim et al.	
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	US-6,280,584	08-28-2001	Kumar et al.	
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	US-6,291,337	09-18-2001	Sidhwani	
	US-6,290,491	09-18-2001	Shahvandi et al.	
	US-2001/0024387-A1	09-27-2001	Raaijmakers et al.	
<u>V</u>	US-6,297,539	10-02-2001	Ma et al.	
<u>CC</u>	US-6,302,964	10-16-2001	Umotoy et al.	

Examiner Signature	C. Chaudhari	Date Considered	10-05
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				Art Unit	2824- 2891
				Examiner Name	Michael K. Luhrs
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C C	US-6,302,965	10-18-2001	Umotoy et al.	
↑	US-6,303,953	10-18-2001	Doan et al.	
↑	US-2001/0029892-A1	10-18-2001	Cook et al.	
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	US-6,315,859	11-13-2001	Donohoe	
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	US-2002/0007790-A1	01-24-2002	Park	
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✓	US-2002/0100418-A1	08-01-2002	Sandhu et al.	
C C	US-6,428,859	08-06-2002	Chiang et al.	

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C C	US-2002/0104481-A1	08-08-2002	Chiang et al.	
↑	US-6,432,831	08-13-2002	Dhindsa et al.	
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	US-2002/0164420-A1	11-07-2002	Derderian et al.	
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	US-2002/0195201-A1	12-26-2002	Beer	
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	US-2003/0003697-A1	01-02-2003	Agarwal et al.	
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↓	US-2003/0023338-A1	01-30-2003	Chin et al.	
C C	US-2003/0024477-A1	02-06-2003	Okuda et al.	

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C.C	US-2003/0027428-A1	02-06-2003	Ng et al.	
↑	US-2003/0027431-A1	02-06-2003	Sneh et al.	
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↓	US-2003/0194862-A1	10-18-2003	Mardian et al.	
C.C	US-2003/0192645-A1	10-16-2003	Liu	

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				Art Unit	2024 2891
				Examiner Name	Michael K. Luhrs
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				Application Number	10/767,298-Conf.# 5002
				Filing Date	January 28, 2004
				First Named Inventor	Lingyi A. Zheng
				Art Unit	2824-2891
				Examiner Name	Michael K. Luhrs
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				Application Number	10/767,298-Conf.# 5002
				Filing Date	January 28, 2004
				First Named Inventor	Lingyi A. Zheng
				Art Unit	2824 289/
				Examiner Name	Michael K. Luhre
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Examiner Initials	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		T ²
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				Filing Date	January 28, 2004
				First Named Inventor	Lingyi A. Zheng
				Art Unit	2824- 2891
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				Art Unit	2824- 2891
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